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1	Structural Thermal Stability of Graphene Oxide-doped Copper-cobalt Oxide
2	Coatings as a Solar Selective Surface
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3d transition metal oxides based thin film coatings such as copper-cobalt oxides exhibit high 28 29 absorption in the visible region and low emittance in the infra-red to far-infra-red region of the solar spectrum which is favourable for use as potential selective surface materials in 30 photothermal devices. These materials have the potential to minimize heating while increasing 31 absorption in the operative spectrum range and therefore achieve higher solar selectivity. A 32 series of mixed copper-cobalt metal spinel oxides ( $Cu_x Co_y O_z$ ) doped with graphene oxide thin 33 films were deposited on commercial grade aluminium substrates using a sol-gel dip-coating 34 technique at an annealing temperature of 500 °C in air for 1 h. Characterizations of the 35 synthesized films were carried out by high temperature synchrotron radiation X-ray Diffraction 36 (SR-XRD), UV-Vis, Fourier Transform infrared spectroscopy (FTIR) and X-ray photoelectron 37 microscopy (XPS) techniques. High thermal stability of coatings with multiple phases, binary 38 and ternary metal oxides, was defined through SR-XRD study. FTIR analysis shows moderate 39 (<80%) to high (up to 99%) reflectance in the infra-red region while the UV-Vis investigations 40 demonstrate that, in the visible region, solar absorption increases gradually (up to 95%) with the 41 addition of graphene oxide to the  $Cu_x Co_y O_z$  coatings. With the incorporation of 1.5 wt% of 42 graphene oxide to the copper-cobalt oxide coatings, a high solar selectivity of 29.01 (the ratio of 43 44 the average solar absorptance in visible and the average thermal emittance in infra-red to far infra-red region;  $\alpha/\varepsilon$ ) was achieved. 45

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Key words: Coatings; Sol-gel method; Surface bonding; Thermal stability; Synchrotron
radiation; Fourier transform infrared spectroscopy; X-ray diffraction; X-ray photoelectron
spectroscopy

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#### 52 **1. Introduction**

Over the years, cobalt based mixed metal oxide thin films have been extensively studied 53 by different groups around the world owing to their wide-spread applications<sup>[1-4]</sup></sup>. Pure copper 54 oxide<sup>[5]</sup>, cobalt-copper oxide, manganese-cobalt oxide, nickel-cobalt oxide<sup>[6,7]</sup>, and copper-55 aluminium oxide<sup>[8]</sup> have been used as high performance optical selector or absorbers. The 56 physicochemical and electrochemical properties of  $Cu_x Co_{3-x}O_4$  powder has been investigated for 57 their practical applications as catalysts in oxygen evolutions reactions (EOR)<sup>[9]</sup>. There have been 58 numerous investigations of mixed metal oxide thin films pursuing improved physicochemical, 59 optical, thermal, electro-chemical, photo-chemical, magnetic, dielectric and electro-magnetic 60 properties focusing on their potential practical applications in the areas such as clean energy 61 devices, solar cells, photovoltaics, thermal collectors, solar selective absorbers, and smart 62 windows. Optical characterizations, thermal durability studies, physicochemical and mechanical 63 properties of sol-gel derived Cu–Co oxide coatings have been investigated by other groups<sup>[10,11]</sup>. 64 In a recent study, Rahman et al.<sup>[12]</sup> reported the annealing temperature effects on the 65 morphological, mechanical, solar selective characteristics and local electronic bonding states of 66 metal nitride based thin film coatings. Synthesis mechanisms, cyclic stability and 67 electrochemical performance of graphene-carbon nanotube hybrid films, graphene based 68

69 metal/metal oxides nanocomposite and nano-sized  $Co_3O_4$  materials have been extensively 70 discussed in earlier studies<sup>[13–15]</sup>.

Optical applications of graphene oxide is also well-known<sup>[16]</sup>. The high optical absorption 71 and tuneable optical band-gap are the most appealing characteristics of graphene that make it an 72 ideal material for the effective light harnessing<sup>[17]</sup>. Light absorbing photovoltaic applications of 73 graphene based materials have been reported in an earlier study<sup>[18]</sup>. Optical absorption and power 74 conversion efficiency of layer-transferred graphene in organic hybrid solar cells have been 75 reported<sup>[19]</sup>. The application of graphene in organic photovoltaic devices has been reported by 76 Arco et al.<sup>[20]</sup> and Liu et al.<sup>[21]</sup>. Graphene has been reported to be a promising candidate for 77 offering improved efficiency of light harvesting devices e.g., inorganic, organic<sup>[23,24]</sup>, hybrid<sup>[25]</sup>, 78 and dye sensitized solar cells<sup>[26]</sup>. A series of comprehensive reviews focused on investigating 79 manufacturing aspects, properties, and applications of graphene and graphene-based materials in 80 energy related areas<sup>[27–29]</sup>. Optimization of optical properties of inorganic compounds mixing 81 with graphene oxide forming a hybrid system is also feasible in the development of graphene 82 oxide-based selective surface. As graphene oxide offers good solubility in aqueous and polar 83 84 solvents, the sol-gel method is a feasible technique to prepare graphene oxide based thin films. These coatings exhibit high transmittance and the strong ability to resist abrasion, which make 85 them suitable for applications in some harsh conditions. 86

In the past few years, numerous strategies have been adopted in the design of metal oxide based light harvesting assemblies. For instance, sol-gel derived mixed metal oxides based thin film selective solar surfaces attracted attention due to their flexibility and advantages e.g., costeffective, good thermal and physicochemical stability, easy preparation process, shorter processing time, low-toxicity, less equipment needed, tuneable electronic band gap, and high

92 electron mobility. Despite the availability of numerous literature on metal oxide thin films and graphene oxide thin films for their optical and light harvesting purposes, however, to the best of 93 our knowledge, utilization of mixed metal oxide with graphene oxide thin films as solar selective 94 95 surface is yet to be explored. Nowadays, synchrotron radiation has emerged as a powerful and versatile analytical tool for materials production (e.g., fabrication of microelectronic devices), 96 quality control, and materials evaluation in industrial research and development. Synchrotron 97 radiation possesses some salient features; very high intensity, high brightness, good stability, 98 higher degree of polarization, wide energy range extending from infrared to X-ray wavelengths 99 and so on. In synchrotron radiation, many different beamlines are involved and each beamline is 100 designed for a specific type of research. For different beamlines, various techniques such as X-101 ray absorption, scattering, diffraction, and fluorescence analysis are available for synchrotron 102 103 research. Synchrotron radiation facilities demonstrate superior capabilities to characterise various properties of materials. A wide range of experiments such as structure resolutions, variable 104 temperature studies, structural studies of microporous materials, structure and property 105 106 investigations of solid metal oxides, phase identification and quantification of pharmaceuticals etc-can be successfully conducted at the synchrotron radiation-based powder diffraction (PD) 107 beamline's primary end station. Synchrotron radiation-based spectroscopy is also used to 108 investigate semiconductor and thin film surfaces to realize the interface formation among the 109 constituents. Furthermore, the synchrotron radiation core level emission spectra, the chemical 110 111 composition of the surface of the films, and the detection of the surface core level components can be used to explain the bonding configurations of the thin film coatings. The synchrotron 112 radiation based spectroscopy thus assists revealing the interface formation and new development 113 114 and applications can be evolved. For example, synchrotron radiation based near-edge X-ray

115 absorption fine structure (NEXAFS) initiated by the electron transfer from a core orbital to 116 discrete or quasi-discrete unoccupied levels provide us with valuable information pertinent to the electronic structures and local atomic structures. The local bonding structures around a specific 117 atom such as the coordination number, the bonding length, and the distribution of defects can be 118 estimated by analysing the peak positions of synchrotron radiation based experiments. In a recent 119 work<sup>[30]</sup>, we conducted NEXAFS experiments to sol-gel derived copper-cobalt oxide coatings by 120 measuring the  $CuL_{2,3}$ -edges,  $CoL_{2,3}$ -edges and O K-edges. Our study demonstrated that the local 121 environments of Cu, Co and O remained invariant with the change in the copper to cobalt 122 concentration ratios except for the [Cu]/[Co] = 2 sample whereas the local coordination appeared 123 to slightly change due to the loss of octahedral  $Cu^+$ . The  $Cu-L_3$  and  $Cu-L_2$  absorption edges 124 arisen from the dipole transitions of the  $Cu2p_{1/2}$  for  $L_2$  and  $Cu2p_{3/2}$  for  $L_3$  into the empty d states 125 126 while the Co-L<sub>3</sub> and Co-L<sub>2</sub> absorption edges appeared from Coulomb interactions and exchange interactions of 2p core holes with the 3d electrons. The hybridization of the Co3d states with 127 O2p states and O2p states with Co4sp states and O2p states was extended to a Co higher orbital 128 129 that was seen in the O K-edge NEXAFS peaks of copper-cobalt oxide coatings. In this study, we attempt to develop the graphene oxide as a mixture into the  $Cu_x Co_y O_z$  systems for the 130 development of the thin film based light harvesting devices with improved spectral selectivity. 131 We focus on the structural thermal stability and optical effects of graphene oxide modified 132  $Cu_x Co_y O_z$  composites in order to achieve better solar selective performance of coatings 133 fabricated via dip-coating sol-gel technology. 134

135

#### 136 2. Experimental Methods

#### 137 2.1. Sample preparation methodology

Cobalt (II) chloride (CoCl<sub>2</sub>.6H<sub>2</sub>O, APS Chemical, >99%), copper (II) acetate 138 monohydrate (Cu(OOCCH<sub>3</sub>)2.H<sub>2</sub>O, Alfa Aesar, >98%), propionic acid (C<sub>2</sub>H<sub>5</sub>COOH, Chem 139 Supply, >99%), graphene oxide (concentration 1 mg/cc), and absolute ethanol (E. Mark of 140 141 Germany, >99%.) were used to make the sols for synthesizing thin films. The highly-reflective commercial aluminium material (Anofol, size  $2 \text{ cm} \times 4 \text{ cm}$ ) was used as substrate for the 142 deposition of the coatings. The substrates were cleaned using a hot etching aqueous solution (85 143 °C) prepared by mixing chromium (VI) oxide and phosphoric acid for 10 min in order to remove 144 the alumina layer. Substrates then were rinsed in hot mili-Q water followed by a flush of cooled 145 mili-Q water and dried in a flow of high purity nitrogen gas. 146

In preparing the sols, cobalt (II) chloride (CoCl<sub>2</sub>·6H<sub>2</sub>O, 0.25 mol/L), graphene oxide, and 147 copper (II) acetate monohydrate (Cu(OOCCH<sub>3</sub>)<sub>2</sub>·H<sub>2</sub>O were mixed with absolute ethanol. 148 149 Propionic acid (C<sub>2</sub>H<sub>5</sub>COOH) was used as the complexing agent to the solution. After stirring the mixed solution for 2 h, the resultant solution was used for thin film deposition on aluminium 150 substrates using a dip-coating technique. The dip and withdrawal rate were 180 mm/min and 60 151 152 mm/min, respectively. The sample coating was heated at 150 °C for 60 s. A relative humidity of 50% was maintained during the entire period of the coatings preparation process. The same dip 153 coating process, using same sol solution, was repeated four times to increase the thickness of 154 film with better uniformity. Finally, the samples were annealed at 500 °C in air for 1 h. The 155 heating rate of the furnace for annealing was kept at 50 °C/min and the samples were left in the 156 157 furnace for 10 min after power was turned off.

<sup>159 2.2.</sup> *Characterizations of thin film coatings* 

160 High resolution synchrotron radiation X-ray diffraction (SR-XRD) measurements of the 161  $Cu_{y}Co_{y}O_{z}$  coatings with and without graphene oxide were conducted using the powder diffraction (PD) beamline 10-BM-1 at the Australian synchrotron, Melbourne. The PD beamline 162 163 at Australian Synchrotron utilises a bending magnet source. The beamline was operated at 2.5 GeV which produces a continuous spectrum of photons in the range 5–30 keV with a maximum 164 flux of about 10<sup>13</sup> photons/s at an angular acceptance of 0.23 mrad vertical by 2.5 mrad 165 horizontal. The samples were loaded in 0.3 mm diameter quartz capillaries with diamond 166 powders that are rotated during the measurements. A MYTHEN II microstrip detector system 167 was used in a  $2\theta = 18^{\circ}$  to  $44^{\circ}$  geometry in steps of  $0.002^{\circ}$  for 5 min at each detector settings for 168 SR-XRD data acquisition. The MYTHEN detector consists of 16 position sensitive detectors 169 keeping a 0.2° gap between detector modules. X-rays of wavelength  $\lambda = 0.11267$  nm as 170 171 estimated with a LaB6 standard NIST 660a standard were used for SR-XRD measurements at a beam size of 7 mm in width and 1 mm in height with an exposure time of 145 min. High 172 temperature measurements were achieved using an Anton Parr HTK20 furnace. The real time 173 174 temperature was monitored by a thermocouple in direct contact with the bottom substrate of the coatings close to the irradiated area. The temperature difference between the top of the coating 175 and the bottom of the substrate was calibrated before XRD measurement. The heating and 176 cooling were remotely controlled via a computer interface. The acquired data were processed by 177 using the PDViPeR software in order to obtain the XRD patterns as presented in Figs. 1 and 2. 178

179 Chemical analysis of the outermost 5–10 nm atomic layers of the thin film coatings was 180 performed via the XPS technique. The Kratos Axis-Ultra photoelectron spectrometer uses Al  $K\alpha$ 181 monochromatic X-ray source with beam energy of 1486.6 eV at a power of ~10 mA and ~15\_kV. 182 Square size samples (2 mm × 2 mm) were mounted on steel sample holder. The pressure of the

183 XPS analyser chamber was maintained at  $2.9 \times 10^{-9}$  Torr. The Cu2*p*, Co2*p*, O1*s*, C1*s* 184 photoelectron lines were recorded with a 2D delay line detector. The photoelectron energy scale 185 was calibrated using C1*s* (hydrocarbon; C–H) line-at 284.6 eV. CASA-XPS (Version 2.3.15) 186 software was employed for data processing and curve fitting in order to define the component of 187 photoelectron lines.

188 The photon energy dependence of absorption coefficient helps to study the band structure 189 and the type of electron transition involved in absorption process. In crystalline and amorphous 190 materials the photon absorption obeys the Tauc relation<sup>[31–34]</sup>,

191 
$$\alpha h v = A (h v - E_g)^n \tag{1}$$

where,  $\alpha$  is the absorption coefficient, hv is the incident photon energy, A is an energy 192 independent constant,  $E_g$  is the band-gap energy and n is an index depending on the type of 193 optical transition involved in photon absorption. The index n = 1/2 and 2 for direct and indirect 194 allowed transitions and n = 3/2 and 3 for direct and indirect forbidden transitions, respectively<sup>[32]</sup>. 195 Thus, the direct transition energy gap (direct band-gap energy) can be obtained by plotting hv vs 196  $(\alpha h \nu)^2$  and extrapolating the linear portion of the curve to  $(\alpha h \nu)^2 = 0$  in the energy axis. Similarly 197 the indirect energy band-gap can be found by plotting hv vs  $(\alpha hv)^{1/2}$  and extrapolating the linear 198 portion of the curve to  $(\alpha h v)^{1/2} = 0$  in the *X*-axis. 199

Solar absorptance of the coatings was determined using a double-beam UV–Vis spectrophotometer (Model: UV-670 UV-Vis spectrophotometer, JASCO, USA) with a unique, single monochromator design covering a wavelength range from 190 to 2200 nm. The monochromator consists of a 1200 grooves/mm grating and a photo multiplier tube (PMT)

204 detector for the UV-Vis measurements. The solar reflectance of the thin film coatings were measured using a FTIR spectrometer (Perkin Elmer Spectrum 100 FTIR Spectrometer, USA) in 205 the wavelength of 2.5 to 15.5 µm. The solar absorptance and the thermal emittance of a material 206 can be calculated from measurements of reflectance data from the-visible and infrared ranges of 207 the solar spectrum<sup>[35]</sup>. For a range of solar wavelengths, the total solar absorptance,  $\alpha$  is defined 208 as a weighted fraction between absorbed radiation and incoming solar radiation  $(I_{sol})$ , while 209 thermal emittance,  $\varepsilon$  is defined as a weighted fraction between emitted radiation and the Planck 210 black-body distribution  $(I_p)$  and can be computed using Eqs. (2) and (3)<sup>[35]</sup>. 211

212 
$$\alpha = \frac{\int_{0.19}^{2.2} \mathbf{I}_{sol} (\lambda) (1 - \mathbf{R} (\lambda)) d\lambda}{\int_{0.19}^{2.5} \mathbf{I}_{sol} (\lambda) d\lambda}$$
(2)

213 
$$\varepsilon = \frac{\int_{2.5}^{15.4} I_p(\lambda)(1 - R(\lambda)) d\lambda}{\int_{2.5}^{15.4} I_p(\lambda) d\lambda}$$
(3)

The solar spectrum,  $I_{sol}$  has an air mass (AM) of 1.5 in accordance with the ISO standard 9845-1 (1992). A key parameter of a selective surface is its selectivity, *s*, which is defined as a ratio of the solar absorptance ( $\alpha$ ) to the emittance ( $\varepsilon$ )<sup>[36]</sup> as given in Eq. (4):

217 
$$s = \frac{\alpha}{\varepsilon}$$
(4)

where  $\alpha$  signifies solar absorptance of the coatings estimated in a wavelength range of 190 nm and 2200 nm while  $\varepsilon$  is the emittance in a range between 2.5 µm and 15.5 µm.

220

#### 221 **3. Results and Discussion**

222 3.1. Synchrotron radiation based high resolution XRD studies of the  $Cu_x Co_y O_z$  thin film coatings

223 High temperature synchrotron radiation X-ray diffraction (SR-XRD) measurements of 224  $Cu_{y}Co_{y}O_{z}$  with and without graphene oxide were carried out at room temperature, 100, 200 and 300 °C in a  $2\theta$  geometry from 18° to 44° and 0.002° increment. SR-XRD data presented in Fig. 1 225 226 provide information with the crystalline structures, phase transitions and thermal stability of these coatings. In CuCoO films, multiple and stable phases e.g.,  $CuO_x$ ,  $CoO_x$ ,  $CuCoO_x$  exist until 227 to 300 °C. However  $Cu_x Co_y O_z$  films with 1.5 wt% of graphene oxide, in addition to the above 228 phases, a new phase orthorhombic/CoCu<sub>2</sub>O<sub>3</sub> (space group  $P_{mmn}(59)$ ) was also observed. 229 Monoclinic CuO and hexagonal CoO were the dominant phases in each case (see details in 230 Tables 1 and 2). All the coatings exhibited sharp diffraction lines at all temperatures indicating 231 well defined crystalline phases. Absence of any impurity diffraction peaks reveals that the 232 samples are formed with highly pure precursors. According to Table 1 and Table 2, it is clearly 233 234 seen that the  $2\theta$  positions of all the existing phases are invariant at all measuring temperatures. This reflects the fact that these coatings possess good physical and chemical stability within the 235 operating temperature up to 300 °C. Further observation shows that, with the addition of 1.5 wt% 236 237 of graphene oxide to the copper-cobalt oxide coatings,  $2\theta$  positions of the Bragg reflections are slightly shifting towards the lower angle sides. Due to the lowering of  $2\theta$  values the residual 238 stress of the coatings is reduced. The reduction in internal residual stresses result in lattice 239 distortion. As a consequence of all these factors, it is believed that the coatings achieve greater 240 mechanical and thermal stability in the operating temperature range. The existence of CuO and 241 Co<sub>3</sub>O<sub>4</sub> phases in Cu–Co spinel was detected by SR-XRD analysis. The phase crystallinity of 242 deposited films is also in good agreement with the reported data for CoO<sup>[37]</sup>. However, the CuO 243 lines show the relatively low intensity in the X-ray pattern on these coatings. Incorporation of the 244 245 carbon materials into the mixed metal oxide networks leads to reduction of the scattering

246 intensities of the Bragg reflections. As a result, a subtle shift to smaller *d*-spacings takes place<sup>[38,39]</sup> and spinel structures with enhanced solar selectivity and better physical stability are 247 attained. In these films, copper ions occupy both the tetrahedral and the octahedral sites of the 248 249 spinels. The difference of ionic radius in the tetrahedral and octahedral sites of copper ions (16 pm) and cobalt ions (5.5 pm) also forms a basis for stable structural configurations of these 250 coatings. The films are also stable towards air and moisture having well defined grain 251 boundaries. Cu–Co oxide based thin films form a single phase together with a partially inverted 252 spinel structure<sup>[40-44]</sup> and the segregation of Cu and/or Co oxide phases depends on the Cu/Co 253 ratio and annealing temperatures. Compared to other methods the sol-gel dip-coating method 254 allows the preparation of the  $Co_3O_4$  stable phase at relatively low temperature<sup>[45]</sup>. Annealing of 255 the coatings promotes the migration of the cobalt towards the surface of the coating, where it is 256 oxidized by the atmospheric oxygen and forms the cobalt oxide layer. In a previous 257 publication<sup>[46]</sup>, annealing in air at 500 °C showed that the bulk cobalt films migrate towards the 258 coating surface and forms a layer of Co<sub>3</sub>O<sub>4</sub> having a thickness of 40–50 nm. Since the mixed 259 CuCo oxide thin films can exist in a variety of compositions and crystal structures, their 260 properties also vary widely. As a result, these coatings show a broad variety of potential 261 applications<sup>[47]</sup> such as solar selective surfaces. 262

263

#### 264 3.2. XPS analysis of the $(Cu_x Co_y O_z + graphene \ oxide)$ coatings

The XPS survey scans (not shown here) of these coatings were conducted before etching and after 2 min etching of each sample. An etching of 2 min was chosen to remove the surface contamination around the coatings. The elemental analyses of the copper cobalt oxide thin film coatings with the addition of various wt% of graphene oxide are presented in Table 3. From

Table 3, it is noticed that the carbon content is monotonically increased with the subsequent addition of graphene oxide to the copper cobalt oxide coatings which in turn indicates that the progressive amount of graphene oxide was introduced to the copper cobalt oxide coatings.

272 Fig. 2(a–e) exhibits the deconvolution of the XPS spectra of the  $Cu2p_{3/2}$  peak of  $Cu_x Co_y O_z$  coatings deposited with various wt.% of GO. The two main peaks of  $Cu_{2p_{3/2}}$  and 273  $Cu2p_{1/2}$  ( $Cu2p_{1/2}$  are not shown here) have a binding energy difference of 19.9 eV. The difference 274 in binding energy between  $Cu_{2p_{1/2}}$  and  $Cu_{2p_{3/2}}$  peaks suggests the occurrence of low oxidation 275 states of copper. Our findings herein are in accord with earlier reports<sup>[30,48]</sup>. Compared to the 276 CuO, the covalent nature of the Cu–O bond in copper cobaltite was reduced due to the higher 277 intensity of the satellite peak<sup>[49]</sup>. The deconvolution of  $Cu2p_{3/2}$  photoelectron lines illustrates two 278 curve-fitting components in the vicinity of 932–934.5 eV. The main  $Cu_{2p_{3/2}}$  peaks around 932-279 933 eV are due to the metal (octahedral)  $Cu^+$  ions whereas peaks due to the  $Cu^{2+}$  ions were found 280 at 934–935 eV. It is believed that the Cu $2p_{3/2}$  photoelectron peaks reveal the tetrahedral Cu<sup>+</sup> with 281 its counterpart peak from the octahedral  $Cu^{+[50]}$ . The  $Cu2p_{3/2}$  photoelectron peak with shake-up 282 satellite is ascribed to the copper oxides. In copper cobalt oxide system, the reduction of  $Cu^{2+}$  to 283 Cu<sup>+</sup> has been previously detected<sup>[49,51]</sup>. The oxidation state of copper with different coordinations 284 is possibly due to the evolution of Cu<sup>2+</sup> A-sites originating from the disintegration during the 285 high-temperature annealing at 500 °C. Other reports mentioned that portion of octahedral Cu<sup>2+</sup> 286 (satellites of cupric oxide) further reduced to octahedral  $Cu^{+[52,53]}$ . The  $Cu^{2+}$  ions are merged into 287 the surface octahedral vacancy, accommodating oxygen with neighboring  $Co^{2+}$  ions and thereby 288 forming Cu–O–Co like species<sup>[49,54]</sup>. The Cu<sup>+</sup> and Cu<sup>2+</sup> ions indicate the presence of Cu<sub>2</sub>O and 289 CuO in the copper-cobalt system. The presence of CuO was also confirmed by our synchrotron 290 291 radiation XRD studies.

The XPS spectra of the Co2p peaks and the decomposition of the Co2p<sub>3/2</sub> peak of copper-292 293 cobalt oxide thin film coatings synthesized with various wt% of graphene oxide are presented in Fig. 3(a–e). In each of the Co2p spectrum, two main peaks are assigned as  $Co2p_{3/2}$  and  $Co2p_{3/2}$ . 294 along with a satellite in the neighbourhood of the higher binding energy region of each peaks. In 295 each coating, the peak-fitting of  $Co2p_{3/2}$  and its satellite give rises to three components (See Fig. 296 3(a–e)). Peaks Co $2p_{3/2}$  and Co $2p_{3/2}$  are separated (not shown here) with binding energy of ~16 297 eV due to the spin-orbit coupling of mixed  $Co^{2+}$  and  $Co^{3+}$  ions. The existence of the satellite in 298 the neighbourhood of  $Co_{2p_{3/2}}$  peak implies that the feature of Co ions is occupied in a partial 299 spinel crystal structure. The low intensity of the satellites also confirms the presence of  $Co^{3+}$  ions 300 mixing with  $Co^{2+}$  ions<sup>[41]</sup>. The components i and ii are due to the formation of  $Co_3O_4$ , and  $Co_2O_3$ 301 which are mostly due to octahedral  $Co^{3+}$  or mixed  $Co^{2+}$  and  $Co^{3+}$  bonding states. 302

Formation of  $Co_3O_4$  was also revealed in the high resolution X-ray diffraction studies employed by synchrotron radiation. Since the binding energy of  $Co^{2+}$  is higher than that of  $Co^{3+}$ , the shake-up satellite was mostly recorded above 785 eV and is identified to be contributed from cobalt oxide bonds. From the  $Cu2p_{3/2}$  features, characteristic of copper ( $Cu^{+2}$ ) oxides in tetrahedral coordination, it is seen that the  $Cu^{2+}$  ions partially substitute the  $Co^{2+}$  ions thus forming a lower degree of crystallization of  $Cu^{2+}Co_2^{3+}O_4$  spinel systems<sup>[9,30]</sup>.

Fig. 4(a–e) demonstrates the O1*s* XPS spectra and the corresponding curve-fitting arisen from the decomposition O1*s* peak of  $Cu_x Co_y O_z$  coatings without and with various wt.% of graphene oxide. The decomposition of O1*s* peak and the satellite give out three curve fitting components (Fig. 4(a–e)). All the O1*s* spectrum shows a strong peak with a shoulder at the high energy side which is a typical feature of  $Cu_x Co_y O_z$  coatings<sup>[9]</sup>. Comparatively, flat shoulder peak in the high energy side of O1*s* peak arises from the high volume fraction of surface oxygen and

the low amount of subsurface oxygen in the coated films. Further, the shoulders at the high energy side of the O1*s* peaks are the characteristic feature of the copper-cobalt oxide systems that differentiates them from O1*s* on  $Co_3O_4^{[9]}$ . The decoupling curve-fitting peaks (on the lower energy side) are mostly due to the lattice  $O^{2-}$  in a  $Co_3O_4$  spinel structure while the other peaks (on the higher energy side) are due to the OH-originated groups *e.g.*, carbonate, hydroxyl etc<sup>[9,41,49,55,56]</sup>. It is also assumed that these peaks are arisen from (Cu–O, Co–O) covalent bonds<sup>[30,41]</sup>.

The deconvolution of high resolution C1s XPS data and their corresponding peak-fitting 322 of copper fitting components above 286 eV and 288 eV are the surface contamination of the 323 oxygen, surface oxygen such as chemisorbed water or chemisorbed oxygen O<sup>-</sup> etc introduced 324 during the synthesis and annealing processes of the thin film coatings. In a bulk structure, the 325 oxygen ions near the surface, generally, have lower electron density than the lattice  $O^{2-}ions^{[57]}$ . 326 It is also seen that the coordination number of oxygen ions is much smaller than in cobalt oxide 327 thin film coatings with and without the addition of various wt.% of graphene oxide (Fig. 5). The 328 329 C1s XPS spectra display a single peak at 284.6 eV together with an asymmetrical tail at high energy side. The principal component of decoupled peak represents the graphitic carbon or 330 hydrocarbon bonds (C-C/C-H bonds) at 284.60 eV and the remainder a regular site together 331 with stronger metal-oxygen assigned as C-OH/C-O-C and C=O/O=C-O structures originated 332 from graphite stacking material<sup>[58]</sup>. In Ref. [59],  $\pi - \pi^*$  shake-up at higher energy side 333 corresponding to  $sp^2$  hybridized carbon was noticed. However, in the present investigation no  $\pi$ -334  $\pi^*$  shake-up was identified. A reduction in the peak intensities of C=O/O=C-O bonds was seen 335 on the deconvoluted C1s peak and indicates the incomplete removal of the carbonyl, hydroxyl, 336 and epoxy groups (originated from the oxidation and destruction of the  $sp^2$  bonded pristine 337

graphene) after the heat treatment<sup>[60]</sup>. The C=O bonds were detected at 288.01–288.40 eV which 338 eventually confirmed the presence of C=O bonds observed in O1s spectra at 531.33–531.44 eV. 339 Detailed XPS results of  $Cu_rCo_vO_7$  and  $Cu_rCo_vO_7$ /graphene oxide coatings are tabulated in Table 340 4. The XPS fitting curves of  $Cu_{2p_{3/2}}$ ,  $Co_{2p_{3/2}}$ , O1s and C1s spectra were analysed via CASA 341 XPS 2.3.1.5 software. A slight change in peaks broadening and peaks shifting towards the lower 342 binding energy was noticed while controlled amount of graphene oxide were incorporated to the 343 sol-gel derived copper-cobalt oxide coatings. This peak shifting and peak broadening indicates 344 the appearance of the reduced states of Cu and Co species on the surface. This also reveals the 345 occurrence of a larger number of oxygen vacancies around the surface of the films. However, a 346 subtle peak shift observed in C1s peak towards the higher binding energies reveals that the 347 presence of graphene oxide modifies the bonding environments of the carbon atoms. It is 348 probably due to the variation in the relative proportions of carbon-carbon and carbon-oxygen 349 contributions. The XPS-peak intensity of all the five samples is identical although measured peak 350 intensities varied significantly with the addition of graphene oxide to the copper-cobalt oxide 351 352 films. However, to realize the substantial information of measured XPS peak intensities depth profile analysis of the atoms is essential. 353

354

#### 355 3.3. Energy band-gaps of $(Cu_x Co_y O_z + graphene oxide)$ coatings

The UV-Vis absorptance spectra presented in Fig. 6 were used to inspect the optically induced transition and to acquire information about the band structure of the films. Fig. 6 shows that in the visible range of the spectra, the solar absorptance of these coatings increases with the increase in wavelengths. At a wavelength of 350–460 nm, the absorbance values reach its maximum and then decreases. Another maxima was detected at a wavelength of 1360–1500 nm.

361 The spectral dependence of  $\alpha$  on the photon energy  $(h\nu)$  helps to estimate the energy band-gaps of a material. Photon absorptions in crystalline and amorphous materials are known to 362 follow the Tauc relation as given in Eq. (1). The energy band-gap,  $E_{\rm g}$  involved in CuCoO 363 coatings with and without the addition of graphene oxide was estimated by Tauc plot, by plotting 364 the function  $(\alpha hv)^2$  vs hv (the photon energy), by extrapolating the linear portion of the curve to 365 zero absorption. Tauc plots of hv vs  $(\alpha hv)^2$  for CuCoO coatings with and without the addition of 366 graphene oxide films are shown in Fig. 7 and energy gaps were estimated from the intercepts of 367 368 the linear part of the curves extrapolated to zero in the photon energy axis. The energy band-gap values computed for CuCoO coatings with and without the addition of graphene oxide films are 369 presented in Table 5. The values of direct and indirect transition energy gaps lie between 1.6 and 370 371 2.4 eV. From Table 5 it is found that the energy band-gaps of CuCoO coatings slightly decrease with the subsequent incorporation of graphene oxide to the CuCoO system. This decrease in 372 energy band-gaps play significant role in enhancing the photon absorption capability of these 373 coatings with the subsequent addition of graphene oxide to the CuCoO matrix. 374

#### 375 3.4. Optical properties of mixed ( $Cu_x Co_y O_z$ + graphene oxide) coatings

Fig. 8 shows the UV-Vis spectra of  $Cu_x Co_y O_7$  thin film coatings on aluminum substrates 376 377 with and without the progressive addition of graphene oxide. The solar absorptance of the 378 coatingswas calculated based on the AM1.5 solar spectrum standard using the hemispherical This was recorded via UV-Vis-NIR Jasco V-670 double beam 379 reflectance data. 380 spectrophotometer with 60 mm integrating sphere in the wavelength range of 190 to 2200 nm. 381 The solar absorptance values estimated in terms of reflectance as described by Duffie and Beckman<sup>[35]</sup> are displayed in Table 6. The UV-Vis reflectance data presented in Fig. 8, indicate 382 383 that the coatings offer low reflectance (<50%) to UV light, moderate reflectance (<80%) in the

384 visible spectrum and high reflectance (up to 100%) in the region from infrared to far-infrared of the solar spectrum. In the shorter wavelength region, all the UV-Vis spectra are similar showing 385 an interference peaks and absorption edges which is consistent with previous study by Amir et 386 al.<sup>[7]</sup>. The solar absorptance of the coatings without graphene oxide was found to be 83.4%, 387 however with the addition of 1.5 wt% of graphene oxide, the absorptance increased to 86.14%. 388 Thus, the introduction of controlled amount of graphene oxide to the  $Cu_x Co_y O_z$  thin film 389 390 coatings, the solar absorptance increased significantly. This superior absorptance would make them smart candidates for their practical application as a selective surface. This result is in good 391 agreement with earlier reported sol-gel derived coatings<sup>[61–63]</sup>. Optical absorptance of the 392 copper-cobalt oxide films is influenced by the film thickness, the composition of the substrate, 393 the roughness of the film surface and surface pores among others. Aluminium substrate was used 394 for the films because of its low cost and high reflectivity<sup>[6]</sup>. The highly reflective aluminium 395 surface serves to reflect back the infra-red radiation that penetrates the film coating. The copper-396 cobalt films deposited on the aluminium substrate significantly exhibit higher degree of solar 397 absorption compared to that deposited on a glass substrate<sup>[6]</sup>. A rough surface results in a 398 decrease in reflection of the incident solar energy from the surface and the refractive index is 399 reduced by the presence of pores in the  $Cu_x Co_y O_z$  graphene oxide surface. These factors promote 400 the solar absorptance by means of multiple reflections and resonant scattering in the pores. 401

Fig. 9 shows the FTIR spectra of  $Cu_x Co_y O_z$  thin film coatings with and without the addition of graphene oxide in the wavelength range of 2.5 to 15.5 µm. The thermal emittance of the coatings was calculated in terms of reflectance as described by Duffie and Beckman<sup>[35]</sup> and the corresponding solar selectivity was computed. Results of such calculations are displayed in Table 6. From our measurements, it is observed that in the infra-red and far infra-red region, the

407 solar emittance of the coatings decreased significantly with the progressive addition of the graphene oxide to the  $Cu_r Co_v O_r$  thin film coatings. This reveals that graphene oxide plays a 408 remarkable role in improving the selectivity of the  $Cu_x Co_y O_z$  coatings which reduces the energy 409 410 loss of the selective surface substantially in the infrared region of the spectrum. In all coatings, interference peak and absorption edge were detected at the shorter wavelength sides. It is well 411 known that the interference peaks and the absorption edges are shifted towards the longer 412 wavelengths regions subsequently when graphene oxide was added to the copper-cobalt films. 413 With the incorporation of 1.5 wt% of graphene oxide in the copper-cobalt oxide films, a highest 414 absorptance of 95.19% was achieved while the average absorptance calculated via D-B 415 method<sup>[35]</sup> was 86.14%. Relatively weaker phonon absorption in the vicinity of the wavelength 416 range of 15 µm is also typically exhibited by the copper-cobalt oxide system. Following the same 417 method as described in Ref. [35], an average thermal emittance of 2.97% was recorded by the 418 copper-cobalt coatings doped with 1.5 wt% of graphene oxide and thereby a high solar 419 selectivity of 29.01 was attained for this coating. The increase of absorptance after the addition 420 421 of graphene oxide is referred to the reduction of reflective properties of coating surface. This variation of reflective properties is attributed to the interference phenomena governed by film 422 thickness and refractive index ratios. A non-uniform and inhomogeneous surface reduces the 423 reflection of the incoming solar radiation at the film surface together with the lower refractive 424 index. At the same time, multiple reflections and resonant scattering of the incident solar 425 radiation also take place around the film surface<sup>[64]</sup>. As a result, the solar absorptance is raised up 426 due to the interaction and relaxation mechanisms in the coatings. The higher value of solar 427 absorptance appears to be very promising for application of solar selective surface in 428 429 photothermal collectors. Compared with other reports for sol-gel derived coatings whereby their

 $\alpha = 83\%^{[63]}$ , 80%–85%<sup>[61]</sup> and 80%<sup>[62]</sup>, our findings are quite encouraging. We further assume 430 that the highly reflective aluminium substrates benefits to reflect back the infrared light that pass 431 through the coatings without being absorbed. The transmitted light is reflected back by the 432 substrate which increases the reflectance and reduces the absorptance in the near infrared (NIR) 433 range. As a result, a dark mirror absorber-reflector tandem concept is virtually produced. The 434 solar absorptance and emittance data manifest the fact that addition of a controlled amount of 435 graphene oxide to the copper cobalt oxide coating increases solar selectivity due to the high 436 absorptance in the visible region and increased reflectance in the region from infrared to far-437 infrared of the solar spectrum. Thus, copper-cobalt oxide thin film coatings with the addition of 438 graphene oxide have a great potential to form the basis of an absorber material for solar selective 439 surface applications in photothermal devices. 440

441

#### 442 **4. Conclusion**

The structural characterization, solar selectivity and X-ray photoelectron spectroscopic 443 investigations of the sol-gel derived copper-cobalt oxide thin film coatings with addition of 444 graphene oxide has been investigated. Synchrotron radiation-based high resolution XRD tests 445 show existence of physically, thermally and chemically stable multiple phases. The energy band-446 gaps of these coatings were found to decrease systematically with the progressive addition of 447 graphene oxide to the CuCoO films. The solar absorptance was found to increase with the 448 progressive addition of graphene oxide to the  $Cu_x Co_y O_z$  system while the optical emittance was 449 reduced and thereby the solar selectivity was significant increased. Hence, copper cobalt oxide 450 451 thin films with the addition of graphene oxide display a good promise as a smart solar selective surface for photothermal applications. Such features are interesting aspects which may be 452

453 prevalent in future research concerning designs of superior selective surface. In the present study, we have adopted the sol-gel dip coating method to fabricate mixed metal oxides-based thin film 454 coatings. Sol-gel dip-coating is a popular and versatile technique that can produce mixed metal 455 oxides based thin film coatings with very high solar selectivity up to 44.23. Surface analysis of 456 these coatings via XPS route confirmed the presence of various metal oxide phases (e.g.,  $Cu_2O$ , 457 CuO, Co<sub>3</sub>O<sub>4</sub>) which protect them from further oxidization and corrosion. As a solar selective 458 surface, these types of coatings possess some unique advantages e.g., easy operation, convenient 459 and environment friendly, higher efficiency coupled with lower processing costs over other 460 461 conventional techniques.

462

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Table 1. 20 positions, crystal phases, Miller indices and space groups of sol-gel derived 595

596  $Cu_x Co_y O_z$  coatings as observed from synchrotron radiation XRD studies.

2θ position at room	2θ position at	20 position at	20 position	Crystal structure	Miller	Space group	JCPDS
temperature	100°C	200°C	at 300°C	Crystar structure	index	Space group	reference
20.11 (A)	20.09	20.08	20.08		(200)		
20.48 (B)	20.44	20.46	20.47	Monoalinia/CuO	(111)	$ C_{2}(0)$	00 5000
36.76 (F)	33.75	33.77	33.76	Monochinic/CuO	(022)	- CC(9)	89-3899
41.59 (J)	41.56	41.56	41.58		(222)		
20.11 (A)	20.11	20.10	20.09	_	(222)	_	
23.28 (C)	23.28	23.26	23.26	Cubio/CoCo.O.	(400)	- Ed $3m(227)$	78 1080
33.76 (F)	33.75	33.77	33.76		(440)	Fu-3III(227)	/0-1900
39.15 (G)	39.16	39.14	39.13	G	(622)		
20.11 (A)	20.10	20.09	20.10		(101)	_	
33.16 (E)	33.13	33.15	33.14	Havagonal/CoO	(103)	- <b>D</b> 6-mc(186)	80 2803
39.91 (H)	39.90	39.89	39.89	Tiexagonai/COO	(202)	103110(100)	89-2803
40.98 (I)	40.96	40.97	40.97		(104)	_	
23.84 (D)	23.84	23.85	23.83		(221)	_	
33.76 (F)	33.75	33.75	33.75	Dhomhohodrol/Co	(444)	_	
39.91 (H)	39.90	39.88	39.89		(020)	R-3m(166)	74-1855
41.59 (J)	41.58	41.57	41.59	CuO <sub>2</sub>	(131)	_	
39.15 (G)	39.14	39.13	39.13		(316)		

57.10 (0)	5711	07110	07.10
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Table 2. 20 Positions, crystal phases, Miller indices and space groups of sol-gel derived 

609	$(Cu_x Co_y O_z + 1.5 \text{ wt\% } G)$	O) coatings a	s observed from	n synchrotron 1	radiation XRE	• studies.
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2θ position	20	20	20		Millor	Space	ICDDS
at room	position	position	position	Crystal structure	index	Space	JCFD5
temperature	at 100°C	at 200°C	at 300°C		muex	group	Tererence
20.10 (A)	20.09	20.08	20.08		(200)	_	
20.48 (B)	20.45	20.46	20.47	Monoalinia/CuO	(111)	$C_{\alpha}(0)$	<u> 20 5200</u>
33.74 (F)	33.73	33.74	33.74	Monochine/CuO	(022)	- (0(9)	09-3099
41.57 (J)	41.56	41.56	41.57		(222)		
20.11 (A)	20.11	20.10	20.09		(222)		
23.28 (C)	23.28	23.26	23.26	Cubic/CoCo O	(400)	$\mathbf{F}_{1}$	79 1090
33.76 (F)	33.75	33.77	33.76	$Cubic/CoCo_2O_3$	(440)	- Fd-3m(227)	/8-1980
39.15 (G)	39.16	39.14	39.13	C	(622)	-	
20.11 (A)	20.10	20.09	20.10		(101)		
33.16 (E)	33.13	33.15	33.14		(103)	- <b>D</b> ( $  -$ (196)	00 2002
39.91 (H)	39.90	39.89	39.89	Hexagonal/CoU	(202)	$-Po_3mc(180)$	89-2803
40.98 (I)	40.96	40.97	40.97		(104)	-	
23.84 (D)	23.82	23.83	23.83	NO	(221)		
33.74 (F)	33.73	33.73	33.74	Rhombohedral/	(444)		74 1955
39.90 (H)	39.90	39.89	39.89	CoCuO <sub>2</sub>	(020)	-  K-3m(100)	/4-1855
41.57 (J)	41.57	41.57	41.56		(131)	-	
20.48 (B)	20.84	20.47	20.47		(301)		
23.84 (D)	23.83	23.84	23.83	Orthorhombic/Co	(020)	- Deceme (50)	76 0442
33.74 (F)	33.74	33.73	33.74	$Cu_2O_3$	(302)	- Pininn(59)	/6-0442
39.10 (G)	39.10	39.10	39.09		(620)	-	
10							
		67					
11		C					
12							

- **Table 3.** Atomic compositions of  $Cu_x Co_y O_z$  thin film coatings with and without graphene oxide
- addition before and after etching as estimated via XPS measurements.

Samples	Floments	Atomic percentages	s (at.%) of elements
Samples	Liements	Before etching	After etching
	Cu	12.54	28.66
$C_{\rm H}$ $C_{\rm e}$ $O$	Co	11.67	33.51
$Cu_x Co_y O_z$	0	43.11	33.82
	С	32.67	4.01
	Cu	14.46	30.57
$Cu_x Co_y O_z$	Co	20.58	35.45
+0.1wt%GO	0	40.92	28.66
	С	24.04	5.32
	Cu	19.13	29.87
$Cu_x Co_y O_z$	Со	20.27	34.66
+0.5wt%GO	0	36.08	30.09
	С	24.52	5.38
	Cu	12.96	30.35
$Cu_x Co_y O_z$	Со	15.75	36.71
+1.0wt%GO	0	40.55	27.41
	С	30.74	5.54
	Cu	14.41	28.47
$Cu_x Co_y O_z$	Со	17.83	30.02
+1.5wt%GO	0	39.03	35.19
	С	28.73	6.32
	COX		

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#### **Table 4.** Fitting results of the XPS data of sol-gel derived $Cu_x Co_y O_z$ coatings with and without

#### 632 graphene oxide addition for the core level binding energies.

Samplas	Photoelectron	Donding states	$\mathbf{PE}\left(\mathbf{aV}\right)$	FWHM	Percentage of the
Samples	lines	Boliding states	DE (ev)	(eV)	component (%)
	$Cu^{2}m^{2}/2$	Metal Cu <sup>+</sup> ions (Cu <sub>2</sub> O bonds)	932.52(i)	1.70	68.86
	Cu2p5/2	Metal Cu <sup>2+</sup> ions (CuO bonds)	934.55(ii)	2.00	31.14
	Co2 <i>p3</i> /2	$Co_3O_4$	779.40(i)	2.00	24.54
N		$Co_2O_3$	781.15(ii)	3.26	37.34
Ō	Co2 <i>p3/2</i> sat.	Co <sub>3</sub> O <sub>4</sub> /Co <sub>2</sub> O <sub>3</sub>	785.96(iii)	5.96	38.12
C		Metal oxides (Cu/Co oxides)	529.26(i)	1.00	54.33
'n	O1 <i>s</i>	Metal oxides (Cu/Co oxides)	529.81(ii)	1.30	28.07
0		Surface oxygen/C=O/O=C-O bonds	531.37(iii)	1.30	17.60
		C-C/C-H bonds	284.40(i)	1.30	60.25
	C1s	C-OH/C-O-C bonds	286.28(ii)	1.25	23.01
		C=O/O=C-O bonds	288.14(iii)	1.30	16.74
	C22/2	Metal Cu <sup>+</sup> ions (Cu <sub>2</sub> O bonds)	932.53(i)	1.80	74.03
0	Cu2 <i>p</i> 5/2	Metal Cu <sup>2+</sup> ions (CuO bonds)	934.45(ii)	2.20	25.97
0%	$C_{-}2_{-}2/2$	$Co_3O_4$	779.15(i)	2.00	30.75
wt <sup>6</sup>	C02p5/2	$Co_2O_3$	780.94(ii)	3.30	35.29
.1,	Co2 <i>p3/2</i> sat.	$Co_3O_4/Co_2O_3$	785.78(iii)	6.00	33.96
+ C		Metal oxides (Cu/Co oxides)	529.24(i)	1.07	60.10
Č	O1s	Metal oxides (Cu/Co oxides)	529.78(ii)	1.35	18.58
o,C		Surface oxygen/C=O/O=C-O bonds	531.13(iii)	1.50	21.31
C <sup>8</sup>		C-C/C-H bonds	284.45(i)	1.32	72.82
Cu	C1s	C-OH/C-O-C bonds	286.62(ii)	1.32	14.59
-		C=O/O=C-O bonds	288.01(iii)	1.32	12.59
	C2/2	Metal $Cu^+$ ions ( $Cu_2O$ bonds)	932.40((i)	1.70	73.97
Q	Cu2 <i>p</i> 3/2	Metal Cu <sup>2+</sup> ions (CuO bonds)	934.30(ii)	1.74	26.03
0%	C = 2 = 2/2	$Co_3O_4$	779.12(i)	2.00	28.66
wt <sup>c</sup>	C02p5/2	$Co_2O_3$	780.86(ii)	3.30	34.08
.51	Co2 <i>p3/2</i> sat.	$Co_3O_4/Co_2O_3$	785.71(iii)	5.97	37.25
+ C		Metal oxides (Cu/Co oxides)	529.15(i)	1.08	63.38
$\tilde{\mathbf{O}}_{2}$	O1 <i>s</i>	Metal oxides (Cu/Co oxides)	529.71(ii)	1.32	13.97
0, O		Surface oxygen/C=O/O=C-O bonds	531.10(iii)	1.68	22.65
Ŭ	v	C-C/C-H bonds	284.34(i)	1.34	78.09
Cu	C1s	C-OH/C-O-C bonds	286.79(ii)	1.32	11.24
		C=O/O=C-O bonds	288.58(iii)	1.33	10.68
	C-2 2/2	Metal $Cu^+$ ions ( $Cu_2O$ bonds)	932.34(i)	1.77	67.96
	Cu2 <i>p</i> 3/2	Metal Cu <sup>2+</sup> ions (CuO bonds)	934.28(ii)	2.20	32.04
	$C_{-}2_{-}2/2$	$Co_3O_4$	779.08(i)	2.00	25.47
O D D	C02p5/2	$Co_2O_3$	780.80(ii)	3.29	37.26
VT%	Co2 <i>p3/2</i> sat.	$Co_3O_4/Co_2O_3$	785.67(iii)	5.99	37.27
$\int \mathbf{u}_{x}$	-	Metal oxides (Cu/Co oxides)	529.06(i)	1.10	61.14
0	O1 <i>s</i>	Metal oxides (Cu/Co oxides)	529.49(ii)	1.35	28.93
		Surface oxygen/C=O/O=C-O bonds	530.98(iii)	1.39	9.93

			C-C/C-H bonds	284.37(i)	1.40	62.84
		C1s	C-OH/C-O-C bonds	286.32(ii)	1.36	10.05
			C=O/O=C-O bonds	288.15(iii)	1.35	27.00
			Metal Cu <sup>+</sup> ions (Cu <sub>2</sub> O bonds)	932.30(i)	1.70	68.08
	Q	Cu2 <i>p3/2</i>	Metal $Cu^{2+}$ ions (CuO bonds)	934.25(ii)	2.20	31.92
	$\tilde{O}$		$Co_3O_4$	779.07(i)	2.08	30.65
	vt <sup>0</sup>	Co2 <i>p</i> 3/2	$Co_2O_3$	780.73(ii)	3.30	33.33
	.51	Co2 <i>p3/2</i> sat.	$Co_3O_4/Co_2O_3$	785.64(iii)	5.99	36.02
	- -	1	Metal oxides (Cu/Co oxides)	529.03(i)	1.08	80.16
		O1s	Metal oxides (Cu/Co oxides)	529.45(ii)	1.37	9.65
	о <sup>у</sup> С		Surface oxygen/C=O/O=C-O bonds	530.98(iii)	1.35	10.19
	Ŭ		C-C/C-H bonds	284.60(i)	1.37	77.68
	ŋ	C1s	C-OH/C-O-C bonds	286.55(ii)	1.35	15.17
	Ŭ		C=O/O=C-O bonds	288.81(iii)	1.34	7.14
633	Note: (i	i) – (iii) notations	s in the BE column indicate	the component	t parts of de	econvoluted high
		-, (,		F	1	
634	resolutio	on XPS spectra of	Figs 2-5			
001	resoratio	n m o speedu oi	1 160. 2 0.		)	
C 2 F						
635						
636						
637		<b>F</b> 1 1			1.11.1	
638	Table 5.	• Energy band-ga	ps of $Cu_x Co_y O_z$ thin film coat	ings with the a	addition of g	raphene oxide.
639						
		Coat	tings name	Band-gap, I	$E_{g} (eV)$	
				2 4		
		С	$u_x Co_y O_z$	2.4		
		C Cu <sub>x</sub> Co <sub>y</sub> O	$u_x Co_y O_z$ $v_z + 0.1 wt\% GO$	2.4		
		C Cu <sub>x</sub> Co <sub>y</sub> O Cu <sub>x</sub> Co <sub>y</sub> O	$u_x Co_y O_z$ $u_z + 0.1 wt\% GO$ $u_z + 0.5 wt\% GO$	2.4 2.2 2.1		
		C Cu <sub>x</sub> Co <sub>y</sub> O Cu <sub>x</sub> Co <sub>y</sub> O Cu <sub>x</sub> Co <sub>y</sub> O	$u_{x}Co_{y}O_{z}$ $u_{z} + 0.1wt\% GO$ $u_{z} + 0.5wt\% GO$ $u_{z} + 1wt\% GO$	2.4 2.2 2.1 1.7		
		C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$	$u_x Co_y O_z$ $v_z + 0.1 wt\%$ GO $v_z + 0.5 wt\%$ GO $D_z + 1 wt\%$ GO $v_z + 1.5 wt\%$ GO	2.4 2.2 2.1 1.7 1.6		
640		$C$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$	$u_{x}Co_{y}O_{z}$ $u_{z} + 0.1wt\% \text{ GO}$ $u_{z} + 0.5wt\% \text{ GO}$ $D_{z} + 1wt\% \text{ GO}$ $u_{z} + 1.5wt\% \text{ GO}$	2.4 2.2 2.1 1.7 1.6		
640		C Cu <sub>x</sub> Co <sub>y</sub> O Cu <sub>x</sub> Co <sub>y</sub> O Cu <sub>x</sub> Co <sub>y</sub> O	$u_x Co_y O_z$ $v_z + 0.1 wt\%$ GO $v_z + 0.5 wt\%$ GO $D_z + 1 wt\%$ GO $v_z + 1.5 wt\%$ GO	2.4 2.2 2.1 1.7 1.6		
640		$C$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yC$ $Cu_xCo_yO$	$u_x Co_y O_z$ $v_z + 0.1 wt\% GO$ $v_z + 0.5 wt\% GO$ $D_z + 1 wt\% GO$ $v_z + 1.5 wt\% GO$	2.4 2.2 2.1 1.7 1.6		
640 641		C Cu <sub>x</sub> Co <sub>y</sub> O Cu <sub>x</sub> Co <sub>y</sub> O Cu <sub>x</sub> Co <sub>y</sub> O	$u_x Co_y O_z$ $v_z + 0.1 wt\% GO$ $v_z + 0.5 wt\% GO$ $D_z + 1 wt\% GO$ $v_z + 1.5 wt\% GO$	2.4 2.2 2.1 1.7 1.6		
640 641	Table 6	C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$	$u_x Co_y O_z$ $v_z + 0.1 wt\%$ GO $v_z + 0.5 wt\%$ GO $D_z + 1 wt\%$ GO $v_z + 1.5 wt\%$ GO	2.4 2.2 2.1 1.7 1.6	ith the addi	tion of graphene
640 641 642	Table 6	C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$	$u_x Co_y O_z$ $v_z + 0.1 wt\%$ GO $v_z + 0.5 wt\%$ GO $D_z + 1 wt\%$ GO $v_z + 1.5 wt\%$ GO ties of the Cu <sub>x</sub> Co <sub>y</sub> O <sub>z</sub> thin film	2.4 2.2 2.1 1.7 1.6	ith the addi	tion of graphene
640 641 642	Table 6	C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ 5. Optical propert	$u_x Co_y O_z$ $v_z + 0.1 wt\%$ GO $v_z + 0.5 wt\%$ GO $D_z + 1 wt\%$ GO $v_z + 1.5 wt\%$ GO the Cu <sub>x</sub> Co <sub>y</sub> O <sub>z</sub> thin filt	2.4 2.2 2.1 1.7 1.6	ith the addit	tion of graphene
640 641 642 643	<b>Table 6</b> oxide.	C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ 5. Optical propert	$u_x Co_y O_z$ $v_z + 0.1 wt\%$ GO $v_z + 0.5 wt\%$ GO $D_z + 1 wt\%$ GO $v_z + 1.5 wt\%$ GO ties of the Cu <sub>x</sub> Co <sub>y</sub> O <sub>z</sub> thin fills	2.4 2.2 2.1 1.7 1.6	ith the addit	tion of graphene
640 641 642 643	Table 6 oxide.	C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ 5. Optical propert	$u_x Co_y O_z$ $v_z + 0.1 wt\%$ GO $v_z + 0.5 wt\%$ GO $D_z + 1 wt\%$ GO $v_z + 1.5 wt\%$ GO ies of the Cu <sub>x</sub> Co <sub>y</sub> O <sub>z</sub> thin filt	2.4 2.2 2.1 1.7 1.6 m coatings w	ith the addit	tion of graphene
640 641 642 643	Table 6 oxide. Sampl	C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ Cu_xCo_yO Cu_xCo_yO cu_xCO_yO c	$u_x Co_y O_z$ $v_z + 0.1 wt\%$ GO $v_z + 0.5 wt\%$ GO $D_z + 1 wt\%$ GO $v_z + 1.5 wt\%$ GO ies of the Cu <sub>x</sub> Co <sub>y</sub> O <sub>z</sub> thin film Absorptance, $\alpha$ (%) Em	2.4 2.2 2.1 1.7 1.6 m coatings w	ith the addit	tion of graphene vity, $s = \alpha/\varepsilon$
640 641 642 643	Table 6 oxide.	C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ 6. Optical propert le compositions $Cu_xCo_yO_z$	$u_x Co_y O_z$ $v_z + 0.1 wt\%$ GO $v_z + 0.5 wt\%$ GO $D_z + 1 wt\%$ GO $v_z + 1.5 wt\%$ GO ies of the Cu <sub>x</sub> Co <sub>y</sub> O <sub>z</sub> thin filt Absorptance, $\alpha$ (%) Em 83.40	2.4 2.2 2.1 1.7 1.6 m coatings w iittance, $\varepsilon$ (%) 5.70	ith the addit	tion of graphene vity, $s = \alpha/\varepsilon$ 14.63
640 641 642 643	Table 6         oxide.         Sample         CuxCoy	C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ 6. Optical propertions $Cu_xCo_yO_z$ $O_z + 0.1$ wt% GO	$u_{x}Co_{y}O_{z}$ $u_{z} + 0.1wt\% \text{ GO}$ $u_{z} + 0.5wt\% \text{ GO}$ $D_{z} + 1wt\% \text{ GO}$ $D_{z} + 1.5wt\% \text{ GO}$ ities of the Cu_{x}Co_{y}O_{z} thin fills Absorptance, $\alpha$ (%) Em 83.40 84.00	$\frac{2.4}{2.2}$ 2.1 1.7 1.6 m coatings w iittance, $\varepsilon$ (%) 5.70 5.27	ith the addit	tion of graphene vity, $s = \alpha/\varepsilon$ 14.63 15.85
640 641 642 643	Table 6         oxide.         Sampl         CuxCoy         CuxCoy	C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ 6. Optical propert recompositions $Cu_xCo_yO_z$ $O_z + 0.1$ wt% GO $O_z + 0.5$ wt% GO	$u_x Co_y O_z$ $v_z + 0.1 wt\%$ GO $v_z + 0.5 wt\%$ GO $D_z + 1 wt\%$ GO $v_z + 1.5 wt\%$ GO ies of the Cu <sub>x</sub> Co <sub>y</sub> O <sub>z</sub> thin filt Absorptance, $\alpha$ (%) Em 83.40 84.00 84.30	$\frac{2.4}{2.2}$ 2.1 1.7 1.6 m coatings w iittance, $\varepsilon$ (%) 5.70 5.27 4.80	ith the addit	tion of graphene vity, $s = \alpha/\varepsilon$ 14.63 15.85 17.56
640 641 642 643	Table 6oxide.SampleCuxCoyCuxCoyCuxCoyCuxCoyCuxCoy	C $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ $Cu_xCo_yO$ 6. Optical propert e compositions $Cu_xCo_yO_z$ $O_z + 0.1$ wt% GO $O_z + 0.5$ wt% GO $yO_z + 1$ wt% GO	$u_{x}Co_{y}O_{z}$ $u_{z} + 0.1wt\% \text{ GO}$ $v_{z} + 0.5wt\% \text{ GO}$ $D_{z} + 1wt\% \text{ GO}$ $u_{z} + 1.5wt\% \text{ GO}$ ies of the Cu <sub>x</sub> Co <sub>y</sub> O <sub>z</sub> thin filts $Absorptance, \alpha (\%)  Em$ 83.40 84.00 84.30 85.60	$\frac{2.4}{2.2}$ 2.1 1.7 1.6 m coatings w iittance, $\varepsilon$ (%) 5.70 5.27 4.80 3.20	ith the addit	tion of graphene vity, $s = \alpha/\varepsilon$ 14.63 15.85 17.56 26.75

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**Fig. 1.** Synchrotron radiation X-ray diffraction data of (A)  $Cu_x Co_y O_z$  coatings, and (B)  $Cu_x Co_y O_z$  thin film coatings with 1.5 wt% of graphene oxide at room temperature, 100 °C, 200 °C, and 300 °C acquired at the powder diffraction beamline at Australian Synchrotron, Melbourne.



**Fig. 2.** Decoupling of XPS spectra of  $Cu2p_{3/2}$  peak of CuCoO thin film coatings: (a)  $Cu_xCo_yO_z$  (b)  $Cu_xCo_yO_z + 0.1$ wt.% GO, (c)  $Cu_xCo_yO_z + 0.5$ wt.% GO, (d)  $Cu_xCo_yO_z + 1$ wt.% GO, (e)  $Cu_xCo_yO_z + 1.5$ wt.% GO.



**Fig. 3.** Decoupling of XPS spectra of  $Co2p_{3/2}$  peak of CuCoO thin film coatings: (a)  $Cu_xCo_yO_z$  (b)  $Cu_xCo_yO_z + 0.1wt\%$  GO (c)  $Cu_xCo_yO_z + 0.5wt\%$  GO (d)  $Cu_xCo_yO_z + 1wt\%$  GO (e)  $Cu_xCo_yO_z + 1.5wt\%$  GO.



**Fig. 4.** Decoupling of XPS spectra of O1s peak of CuCoO thin film coatings: (a)  $Cu_xCo_yO_z$  (b)  $Cu_xCo_yO_z + 0.1wt\%$  GO (c)  $Cu_xCo_yO_z + 0.5wt\%$  GO (d)  $Cu_xCo_yO_z + 1wt\%$  GO (e)  $Cu_xCo_yO_z + 1.5wt\%$  GO.



**Fig. 5.** Decoupling of XPS spectra of C1*s* peak of CuCoO thin film coatings: (a)  $Cu_xCo_yO_z$  (b)  $Cu_xCo_yO_z$  + 0.1wt% GO (c)  $Cu_xCo_yO_z$  + 0.5wt% GO (d)  $Cu_xCo_yO_z$  + 1wt% GO (e)  $Cu_xCo_yO_z$  + 1.5wt% GO.



**Fig. 7.** Estimation of energy band-gaps of sol-gel derived  $Cu_x Co_y O_z$  thin film coatings without and with the addition of graphene oxide.



